Donald L. Stephens, Jr.
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For: RETICLE MANIPULATORS AND RELATED METHODS
FOR CONVEYING THIN, CIRCULAR RETICLES AS USED IN
CHARGED-PARTICLE-BEAM MICROLITHOGRAPHY
Inventor(s): Kikuchi et al.
Date of Deposit: August 5, 2003

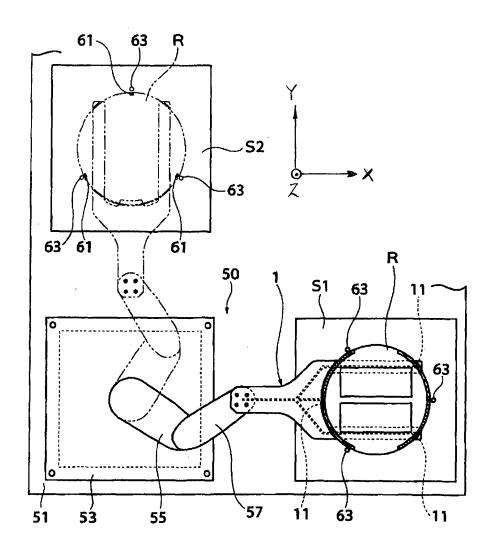
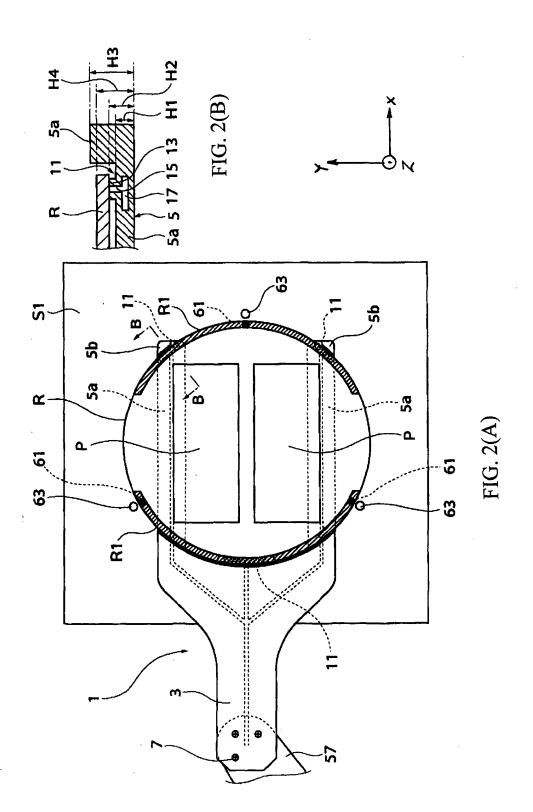
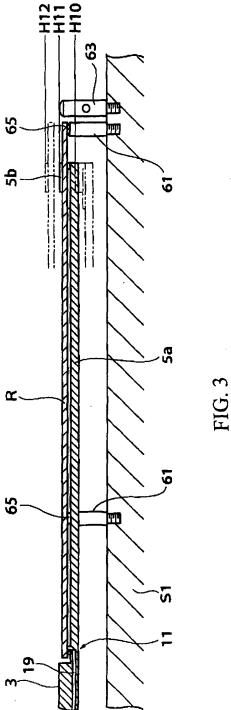


FIG. 1

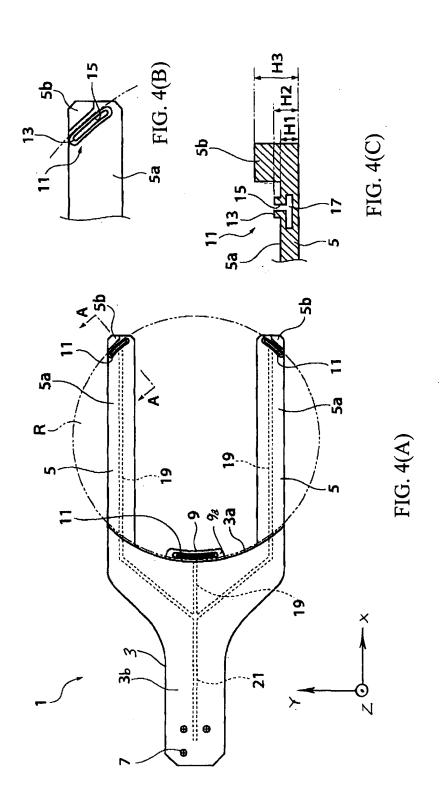
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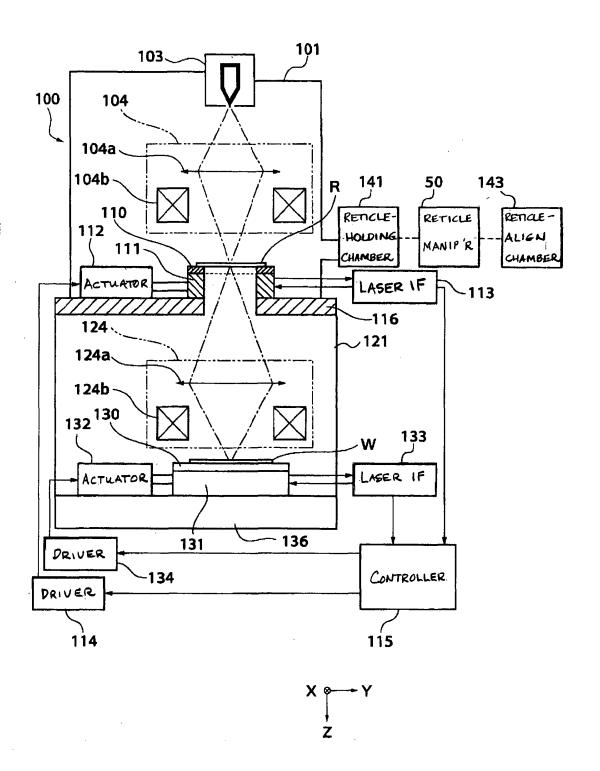


FIG. 5